

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: KOBAYASHI

Application No.: 10/563,302

Filed: 1/4/2006

Title: ELECTROSTATIC CHUCK FOR SUBSTRATE STAGE, ELECTRODE USED
FOR THE CHUCK, AND TREATING SYSTEM HAVING THE CHUCK AND
ELECTRODE

Art Unit: 2836

Exr.: T. MAI

CONF. No.: 8395

AMENDMENT and
REQUEST FOR INTERVIEW

MS: AMENDMENT

December 2, 2009

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 2, 2009, please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the Claims;

Remarks are included following the amendments.